

22nd IEEE International Conference on Micro Electro Mechanical Systems

MEMS 2009

Sorrento, Italy



25-29 JANUARY 2009 • HILTON SORRENTO PALACE

The MEMS Conference series began in 1987 and since 1999 it has been known as the IEEE International Conference on Micro Electro Mechanical Systems. Reflecting the rapid proliferation of microsystems in all venues of life due to the commitment and success of the research community, the MEMS Conference series has evolved into the premier annual event reporting research results on every aspect of microsystems technology. In recent years, it has attracted more than 800 participants, 750+ abstract submissions and has presented over 200 select papers in non-overlapping podium and poster/oral sessions. Its single-session format provides ample opportunity for interaction between attendees, presenters and exhibitors. The 22nd IEEE International Conference on Micro Electro Mechanical Systems (MEMS 2009) will be held in Sorrento, Italy on 25-29 January 2009 at the Hilton Sorrento Palace.

The city of Sorrento appears suddenly, just after the bend of Scutolo Point, on the road which takes you from Naples to the Amalfi Coast. The appearance is beautiful and yet dramatic, with rock peaks falling into the sea and with a breathtaking landscape. The town seems suspended between the blue sky and blue crystal clear sea. The legend tells that in the waters of Sorrento, the mythical Mermaids tempted Ulysses with an enchanting song, and when he refused to listen to the mermaids they decided to turn into rocks. Today, the rocks are called the Galli Islands. Visit nearby Sorrento attractions - from the coast of Capri to the culture of Pompeii, just 15 miles away.

Pre and Post-Conference tour options are outlined on the Conference web-site.

Unwind and enjoy the Hilton Sorrento Palace overlooking the Bay of Naples. A one hour drive from Naples Airport, this Sorrento hotel is a 10 minute walk from the beach and town centre. Stretch out in one of the hotel's terrace sunbeds, dive into the Roman-themed indoor swimming pool or enjoy a cocktail at Pagoda Bar and glimpse Mount Vesuvius in the distance.



Conference Co-Chairs

Christofer Hierold
ETH Zürich, SWITZERLAND

Pasqualina M. Sarro
Delft University of Technology, THE NETHERLANDS

Abstract Classification List

- Fabrication and Packaging Technologies
- Materials and Device Characterization
- Design, Simulation, and Theoretical Concepts with Experimental Verification
- Mechanical Sensors and Systems
- Physical MEMS
- RF MEMS
- Biomedical and Chemical Micro Sensors and Systems
- Micro-Fluidic Components and Systems
- Micro-Actuators
- Energy and Power MEMS
- Nano-Electro-Mechanical Devices and Systems

Abstract Deadlines

Abstracts Due:

24 August 2008

Notice of Acceptance:

26 September 2008

Final Camera Ready Due:

21 October 2008

EARLY BIRD Registration
before 30 September 2008

www.mems2009.org

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